L Number	Hits	Search Text	DB	Time stamp
-	10	(LPD or light near3 point near3 defect and epitax$4 near3 wafer) and nitrogen and 117/$4.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/27 13:28
-	44	(LPD or light near3 point near3 defect same epitax$4 near3 wafer and defect near4 free same (epitax$4 near3 (film or layer))) and 117/$4.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/27 13:49
-	19	(LPD or light near3 point near3 defect) same epitax$4	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/27 14:15
-	58	(LPD or light near3 point near3 defect) same (cop or crystal near4 particle)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/27 14:25
-	39	(LPD or light near3 point near3 defect) and epitax$4 near3 wafer	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/27 14:29
-	60	(denud$3 or dz) same epitax$4 and (silicon near4 wafer)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/27 15:28
-	19	((denud$3 or dz) same epitax$4 and (silicon near4 wafer)) and defect near1 free	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/27 15:39
-	27	SUMITOMO.as. and epitax$4 near3 wafer and dop$3 near4 nitrogen	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/01/28 14:15

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